

<b>Search Notes</b> 	<b>Application/Control No.</b> 10/765,815	<b>Applicant(s)/Patent under Reexamination</b> POSPICHAL ET AL.
	<b>Examiner</b> Tony Chuo	<b>Art Unit</b> 1745

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner